IME-03-005

January 5 , 2006

To: Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Fr: George O. Saile, Reg. No. 19,572
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Poughkeepsie, NY 12603

Subject:

| Serial No.   10/748,736   12/30/05 |

Wong Ee Hua et al.

WAFER LEVEL SUPER STRETCH SOLDER

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Enclosed is Form PTO-1449, Information Disclosure Citation In An Application.

The following Patents and/or Publications are submitted to comply with the duty

of disclosure under CFR 1.97-1.99 and 37 CFR 1.56.

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States
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P.O. Box 1450, Alexandria, VA 22313-1450, on January 6 , 2006.

Stephen B. Ackerman, Reg. # 37761

Signature/Date _____ 1/6/06

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U.S. Patent 4,545,610 to Lakritz et al., "Method for Forming Elongated Solder Connections Between a Semiconductor Device and a Supporting Substrate," discloses a process for forming elongated solder terminals to connect a plurality of pads on a semiconductor device to a corresponding plurality of pads on a supporting substrate.

U.S. Patent 6,432,744 to Amador et al., "Wafer-Scale Assembly of Chip-Size Package," discloses a wafer-scale assembly apparatus for integrated circuits and method for forming the wafer-scale assembly.

Sincerely,

Stephen B. Ackerman,
Reg. No. 37761

Form PTO-1449

INFORMATION DISCLOSURE CITATION
IN AN APPLICATION

(Use several sheets if necessary)

OIPE UP58 JAN 0 9 2006 PATENT & TRADEMARK OFFICE

Docket Number (Optional)	Application Number
ImE-03-005	10/748,736

Applicant
Wong Ee Hua et al.

Filing Date	Group Art Unit
12/30/03	

U. S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	4 5 4 5 6 1 0	10/8/85	Lakritz et al.	29	589	11/25/83
	6 4 3 2 7 4 4	8/13/02	Amador et al.	438	108	10/31/98

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation YES	NO

OTHER DOCUMENTS *(Including Author, Title, Date, Pertinent Pages, Etc.)*

EXAMINER	DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.